



REPLY UNDER 37 C.F.R. § 1.116
EXPEDITED PROCEDURE
TECHNOLOGY CENTER ART UNIT 1763

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:
HONGO *et al.*

Confirmation No. 4649

RECEIVED

SEP 30 2003

TC 1700

Application No.: 09/815,305

Filed: March 23, 2001

ART UNIT: 1763

Title: PLASMA PROCESSING APPARATUS
HAVING AN EVACUATING ARRANGEMENT TO
EVACUATE GAS FROM A GAS-INTRODUCING
PART OF A PROCESS CHAMBER

Examiner: ALEJANDRO MULERO, L.

* * * *

September 24, 2003

AMENDMENT AFTER FINAL UNDER 37 C.F.R. § 1.116

Hon. Commissioner of Patents
Washington, DC 20231

Sir:

Responsive to the Office Action dated June 4, 2003, please amend the above-identified application as follows.